

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Shoji Miyazaki et al.  
Appl. No. : 10/809,217  
Filed : March 25, 2004  
For : BIOSENSOR, THIN FILM ELECTRODE FORMING METHOD,  
QUANTIFICATION APPARATUS, AND QUANTIFICATION  
METHOD  
Customer No. : 1912  
Examiner : Alexander Stephan Noguerola  
Art Unit : 1753

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Information Disclosure Statement is being filed to supplement the Information Disclosure Statement filed on May 20, 2010 in connection with the above-identified application.

In accordance with the duty of disclosure under 37 C.F.R. §1.56, applicants would like to direct the Examiner's attention to the references that are listed on the attached form PTO/SB/08A (4 pages).

Applicants are submitting the subject Supplemental Information Disclosure Statement pursuant to 37 C.F.R. §1.97(b)(4) before the mailing of a first Office Action after the filing of the Request for Continued Examination filed on May 20, 2010. Accordingly, no fee is deemed necessary in connection with the filing of this Supplemental Information Disclosure Statement. However, if any fee is required in connection with the submission of this Supplemental Information Disclosure Statement or to maintain the pendency of the subject application, authorization is hereby given to charge the amount of any such fee to Deposit Account No. 01-1785.

Respectfully submitted,

AMSTER, ROTHSTEIN & EBENSTEIN LLP  
Attorneys for Applicants  
90 Park Avenue  
New York, New York 10016  
(212) 336 8000

Dated: June 2, 2010  
New York, New York

By Alan D. Miller/  
Alan D. Miller, Reg. No. 42,889